

IN THE UNITED STATES PATENT AND TRADEMARK OFFIGE

In re Application of:

Kar Roy, et al.

Serial No.: 10/073,751

Filed: February 9, 2002

For: Method for Fabricating a Metal

Resistor in an IC Chip and Related

Structure

Art Unit: 2815

Examiner: Chu, Chris C.



AMNENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the *Final Office Action* dated May 21, 2003 in the above-referenced patent application. Please enter and consider the following amendments and remarks.